

## Procedural Review Voting Sheet 2014 Cycle 3

REGION: **North America**  
 COMMITTEE: **Silicon Wafer**  
 EVENT: **SEMICON West 2014**  
 DATE OF MEETING: **07/08/2014**  
 PLACE OF MEETING: **Marriott Hotel, San Francisco, California**  
 COMMITTEE CO-CHAIRS: **Dinesh Gupta (STA), Noel Poduje (SMS)**  
 SEMI STAFF: **Kevin Nguyen**

A&R Voter: Name/Company  
 Date: 200X/MM/DD

### I. Document Number & Title

<b>Document 4844C</b>	<b>New Standard: Guide for the Measurement of Trace Metal Contamination on Silicon Wafer Surface by Inductively Coupled Plasma Mass Spectrometry</b>
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### II. Tally (Staff to fill in)

**Voting Tally: As-cast tally after close of voting period**

A minimum of 60% of the voting interests that have voting members within the technical committee must return votes. (Regulations ¶ 9.6.1)

	Return		Distribution		Return Rate	
Yellow	62	÷	92	=	67.4%	>=60%
Lilac & Others	33					
Total Vote	95					
Reject	0					
Accept	36					

<b>A&amp;R</b>		<b>Not approved</b>
		<b>Reason:</b>

### III. Rejects

There was no reject received for ballot 4844C.

### IV. Comments

#### Comment 1

Comment	Referenced Section	<b>*TF/Committee to fill in if necessary</b>	
	From	Jean-Marie Collard (Solvay)	
	Comment	Well done	
	Discussion		
Action proposed	Editorial Change	<input checked="" type="checkbox"/>	The committee agreed to do one of the following actions.
			<b>*No motion is required in this step.</b>
		<input checked="" type="checkbox"/>	No further action was taken by the committee.
		<input type="checkbox"/>	Refer to the task force for more consideration.
		<input type="checkbox"/>	Other
Action proposed			Case 1: No vote in this section :
			<b>To be included and voted on in <u>§ 5. Summary of Editorial Changes.</u></b>
			Case 2: Voted in this section :
			<b>Original section number and at least one full sentence are required in "FROM" and "TO" fields.</b>
		1	FROM: Section xxx
			To: Section xxx
			Justification (If necessary)
		2	FROM: Section xxx
To: Section xxx			
Justification (If necessary)			

Motion by/2nd	Name (Company)/Name (Company)
Vote	XX-XX Motion passed (or failed)
A&R	Not approved
	Reason:

## V. Summary of Editorial Changes

There was no editorial change proposed for ballot 4844C.

## VI. Approval Conditions Check

**APPROVAL CONDITION 1:** All negatives have been discussed and were withdrawn, found not related, or not persuasive. (Regulations ¶ 9.6.2)

**APPROVAL CONDITION 2:** At least 90% of the sum of the valid accept and reject votes must be accept. (Regulations ¶ 9.6.3)

**Note:** if both approval conditions are not satisfied, the document fails.

Approval Rate	=	Accepts	/	(Accepts + Valid)	=		>=90%
		36		36		100.0%	

A&R	Not approved
	Reason:

## VII. Safety Check

See § 14 of the Regulations for further information

Motion:	x	This is not a Safety Document: when all safety-related information is removed, the document is still technically sound and complete.
		This is a Safety Document: when all safety-related information is removed, the document is not technically sound and complete.
		Safety Checklist (Regulations ¶ 14.3) is complete and has been included with the document throughout the balloting process.
Motion by/2nd by	Noel Poduje (SMS)/Naoyuki Kawai (Tokyo University)	
Discussion	None	
Vote	14-0 Motion passed	
A&R	Not approved	

	<b>Reason:</b>
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## VIII. Intellectual Property Check

**Note: This ballot may be all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See § 15 of the Regulations for further information**

x	The meeting chair asked those present in person or by electronic link, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline.	
x	No potentially material patented technology or copyrighted items are known	<b>GO TO SECTION IX</b>
	Potentially material patented technology or copyrighted items are known but a Letter of Assurance (LOA) or copyright release for such material has been obtained or presented to the committee.	<b>GO TO SECTION IX</b>
	Potentially material patented technology or copyrighted items are known but an LOA or copyright release for some of the material(s) has NOT been obtained or presented to the committee	
<b>MOTION</b>	<input type="checkbox"/>	Ask ISC for special permission to publish
	<input type="checkbox"/>	Quit activity
	<input type="checkbox"/>	Wait for LOA for patented technology or release of copyrighted items.
	<b>Motion by/2<sup>nd</sup> by</b>	Name (Company)/Name (Company)
	<b>Discussion</b>	XXXX
	<b>Vote</b>	XX-XX
	<b>Final Action</b>	<input type="checkbox"/> Motion Passed
		<input type="checkbox"/> Motion Failed
<b>A&amp;R</b>	<b>Not approved</b>	
	<b>Reason:</b>	

\* Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this ballot.

## IX. Action for this document

<b>Motion</b>	x	This document passed committee review as balloted and will be forwarded to the A&R for procedural review.
	<input type="checkbox"/>	This document passed committee review with editorial changes and will be forwarded to the A&R for procedural review.
	<input type="checkbox"/>	This document failed committee review and will be returned to the task force for rework.
	<input type="checkbox"/>	This document failed committee review and work will be discontinued.
	<b>Motion by/2<sup>nd</sup> by</b>	Noel Poduje (SMS)/Naoyuki Kawai (Tokyo University)
	<b>Discussion</b>	None
	<b>Vote</b>	15-0
	<b>Final Action</b>	<input checked="" type="checkbox"/> Motion passed
		<input type="checkbox"/> Motion failed

A&R	<input type="checkbox"/>	Approved
	<input type="checkbox"/>	Not approved
	Reason:	